

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Yasuo KOBAYASHI, et al. **Confirmation No.: 7185**  
U.S. Serial No. : 10/549,859  
Filed : June 6, 2006  
Examiner : Michael G. Miller  
Group Art Unit : 1792  
For : PLASMA-ASSISTED DEPOSITION METHOD AND PLASMA-  
ASSISTED DEPOSITION SYSTEM

**AMENDMENT RESPONSE UNDER 37 CFR 1.114**

**Mail Stop: RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Advisory Action mailed February 11, 2011, and the Final Office Action of November 1, 2010, to which the time for response was set to expire February 1, 2011, which response date is extended until May 2, 2011 (May 1, 2011= Sunday), by the enclosed three-month extension request and fee charge authorization, please amend the application as set forth below and consider the following remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.